

**RECEIVED
CENTRAL FAX CENTER**

DEC 20 2004

PATENT
Customer No. 23494
Attorney Docket No. TI-31620
Application No.: 10/085,753

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
TSUGA et al.)	Group Art Unit: 1746
)	
Application No.: 10/085,753)	Examiner: Michael Kornakov
)	
Filed: February 28, 2002)	
)	
For: METHOD AND DEVICE FOR)	
REMOVING PARTICLES ON)	
SEMICONDUCTOR WAFERS)	

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a three month extension of time to reply to the
Office Action dated June 18, 2004, December 18 being a Saturday.

Please grant any extensions of time required to enter this response and charge
any required fees to the Texas Instruments Incorporated Deposit Account 20-0668.

Respectfully submitted,

Dated: December 20, 2004

By: 
Jonathan A. Hack
Reg. No. 47,623